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**CONFIRMATION NO. 1616** Bib Data Sheet

SERIAL NUMBER 09/839,139	FILING DATE 04/23/2001 RULE	C	372	GROUP ART UNIT 2881		ATTORNEY DOCKET NO. 862.C2205		
APPLICANTS Yashiyuki Nagai, Tochigi, JAPAN; Naoto Sano, Tochigi, JAPAN;								
** CONTINUING D	ATA **************	ann Nome	~ ml					
** FOREIGN APPLICATIONS ************************************								
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/13/2001								
Foreign Priority claimed			STATE OR COUNTRY JAPAN	SHEETS DRAWING 11		TOTAL CLAIMS 24		INDEPENDENT CLAIMS 6
ADDRESS 05514								
TITLE  Laser oscillation apparatus, exposure apparatus, semiconductor device manufacturing method, semiconductor manufacturing factory, and exposure apparatus maintenance method								
	·				All Fees  1.16 Fees (Filing)			
RECEIVED No	ES: Authority has been of the charge/c	Paper POSIT ACCOUNT		1.17 Fees ( Processing Ext. of time )				
1022 No	o for following		1.18 Fees (Issue)					
			☐ Credit					